



1100 Crescent Green
Suite 206
Cary, North Carolina 27511
tel: 919-854-1844
fax: 919-854-2050
www.coatsandbennett.com

RECEIVED
APR 25 2000
Patents, Trademarks,
Copyrights, Trade Secrets,
Licensing and
Related Litigation

April 18, 2000

BOX PATENT APPLICATION

Honorable Commissioner of Patents
and Trademarks
Washington, D.C. 20231

RE: U.S. Patent Application

Inventors: David R. Irvin and I. Nelson Wakefield

WIRELESS HEADSET WITH AUTOMATIC POWER CONTROL

Dear Sir:

Enclosed please find a supplemental Information Disclosure Citation and related patents.

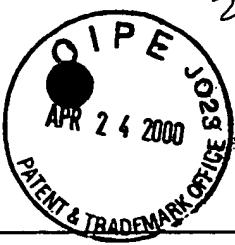
Respectfully submitted,

COATS & BENNETT, P.L.L.C.

By:

John R. Owen
Registration No. 42,055

JRO/kaw
Enclosures
P-4015.552



2747

Sheet 1 of 1

MAY 25 2000
GROUP 2700

RECEIVED

FORM PTO-1449

**INFORMATION DISCLOSURE CITATION
IN AN APPLICATION PURSUANT TO
37 CFR §1.97 & 1.98**

Docket Number:	Serial Number:
P-4015.552	09/507586
Applicant:	
Ericsson, Inc.	
Filing Date:	Group:
TBA	

U. S. PATENT DOCUMENTS

Examiner

Filing Date

Initial	Patent No.	Date	Name	Class	Subcl	If Approp.
A	5,726,480	1998	Pister	257	415	
B	6,012,822	2000	Robinson	362	103	
C	5,659,195	1997	Kaiser et al.	257	415	
D	5,663,507	1997	Westervelt et al.	73	727	

FOREIGN PATENT DOCUMENTS

Translation

	Patent No.	Date	Name	Class	Subcl	Yes	No

OTHER DOCUMENTS (including author, title, date, pages, etc.)

E	Application Note AN-374 from Analog Devices, "Using Accelerometers in Low g Applications" by Charles Kitchin, March 1995, 6 pages
F	Article from www.eetimes.com , "MEMS Accelerometer Designed Into Consumer Applications" by Stephan Ohr, March 11, 1998, 3 pages
G	Article from IBM Systems Journal, "Inertial Proprioceptive Devices: Self-Motion-Sensing Toys and Tools" by C. Verplaetse, May 10, 1996, 12 pages
H	Dissertation Abstract from the Department of Electrical Engineering and Computer Sciences, University of California at Berkeley, "A Surface Micromachined Accelerometer with Integrated CMOS Detection Circuitry" by Weijie Yun, 1 page

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation not in conformance and not considered. Include copy of this form with next communication to the applicant.